



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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APR 09 2003
GROUP 1700

In re PATENT APPLICATION of

Jae-dong Lee et al.

Group Art Unit: 1765

Serial No.: 10/023,948

Examiner: Lynette T. Umez Eronini

Filed: December 21, 2001

For: CHEMICAL MECHANICAL POLISHING SLURRY

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Honorable Commissioner of
Patents and Trademarks,
Washington, D.C. 20231

Sir:

In response to the Office Action of March 20, 2003, Applicants elect the invention of Group I, Claims 1-12, drawn to polishing slurry. The election is without traverse.

Respectfully submitted,

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Dated: April 8, 2003